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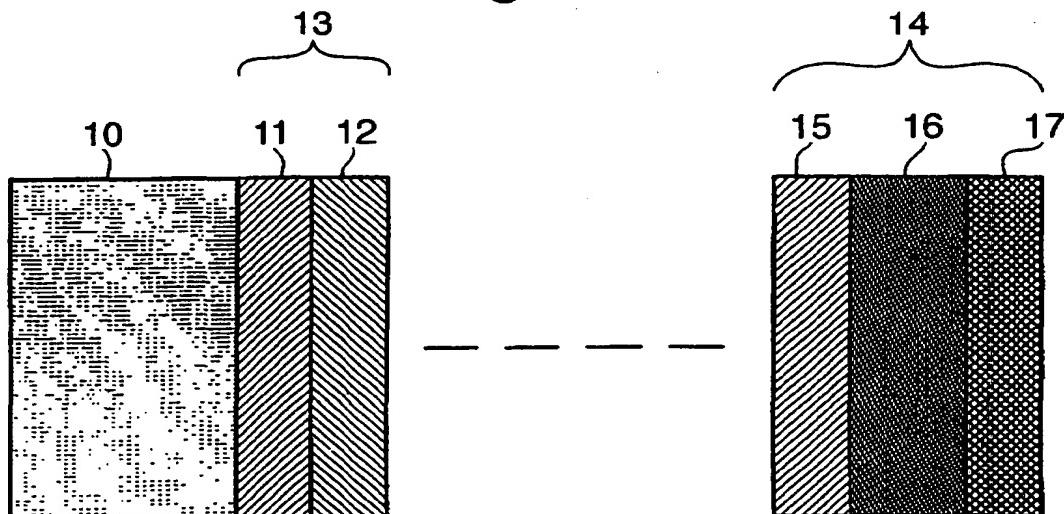
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(54) EUV-Lithographic projection apparatus comprising an optical element with a capping layer

(57) A lithographic projection apparatus comprises an optical element such as a multilayered EUV mirror (10,13,14) with protective capping layers (17) of diamond-like carbon (C), boron nitride (BN), boron carbide

(B₄C), silicon nitride (Si₃N₄), silicon carbide (SiC), B, Pd, Ru, Rh, Au, MgF₂, LiF, C₂F₄ and TiN and compounds and alloys thereof. The final period (11,12) of a multilayer coating may also be modified (15,16) to provide improved protective characteristics.

Fig.13.





European Patent
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EUROPEAN SEARCH REPORT

Application Number

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